



RECEIVED
JUN 17 2003
TC 1700

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

5 Applicant: Chih-Ning Wu Examiner: Umez Eronini, Lynette T
Filing Date: 07/16/2001 Art Unit: 1765
App. No.: 09/682,054 Docket No.: NAUP0374USA

10 Title: EXTRUSION-FREE WET CLEANING PROCESS FOR COPPER-DUAL
 DAMASCENE STRUCTURES

15 To: Commissioners for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Subject: Response to the Office action dated 03/14/2003

20

Dear Sir or Madame:

INTRODUCTORY COMMENTS

25

In response to the Office action identified above, the above-identified application is to be amended as indicated in the following sections. Consideration of all amendments is politely requested.

30